014AUS PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

pplacant : Minoru Umemoto et al.

Group Art Unit 1793

Serial No. : 10/585,707

Filed : July 19, 2006

For : PROCESS OF FORMING

ULTRAFINE CRYSTAL LAYER,
MACHINE COMPONENT HAVING
ULTRAFINE CRYSTAL LAYER
FORMED BY THE ULTRAFINE
CRYSTAL LAYER FORMING
PROCESS, PROCESS OF
PRODUCING THE MACHINE
COMPONENT, PROCESS OF
FORMING NANOCRYSTAL LAYER,
MACHINE COMPONENT HAVING
NANOCRYSTAL LAYER FORMED
BY THE NANOCRYSTAL LAYER

FORMING PROCESS, AND PROCESS OF PRODUCING THE

MACHINE COMPONENT

Examiner : Christopher S. Kessler

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents Alexandria, VA 22313-1450

Dear Sir:

Pursuant to the duty of disclosure, enclosed is a form PTO-1449 listing one reference relevant to the above-identified application. A copy of each of the references is also enclosed herewith.

This information disclosure statement is being filed after three months from the filing date of the above-identified application and after the first office action on the merits.

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Each item of information contained in the information disclosure statement was first cited in a communication from a foreign patent office (Japanese Patent Office) in the counterpart foreign application not more than three months prior to the filing of the information disclosure statement.

The prior art reference cited by the Japanese Patent Office is a non-English material, i.e., a Japanese laid-open publication. Therefore, the applicant submits herewith an English abstract of the publication.

The applicant respectfully requests that the references disclosed in the statement be considered in the substantive examination of this case.

Respectfully submitted,
MURAMATSU & ASSOCIATES

Dated: 12/20/28/0

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